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03500.015262.

PATENT APPLICATION

NOW 2 8 2004 SE	THE UNITED STATES PATE	ENT AND TRADEMARK OFFICE
In re Application	on of:) : Examiner: Marianne L. Padgett
TAKESHI SHI	SHIDO ET AL.)
Application No	o.: 09/822,191	: Group Art Unit: 1762)
Filed: April 2,	2001)
For: EXHAU PLASMA	ST PROCESSING METHOD, A PROCESSING METHOD ASMA PROCESSING	;; ,) ;) : April 27, 2004

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

RESPONSE TO RESTRICTION REQUIREMENT

Sir:

a) <u>Introductory Comments</u>

In response to the written restriction requirement dated April 7, 2004, in the subject application, please consider the remarks which follow.